

10/572842
AP20 Res UFGTTO 21 MAR 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Atty. Docket

LOOS et al.

NL 031158

Serial No.

Group Art Unit

Filed: CONCURRENTLY

Ex.

METHOD AND APPARATUS FOR PROTECTING A RETICLE USED IN CHIP
PRODUCTION FROM CONTAMINATION

Commissioner for Patents
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Prior to calculation of the filing fee and examination, please
amend the above-identified application as follows: